



4-14-05

IFW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Nagashima et al.

Application No.: 10/662,862

Filed: 9/15/2003

Title: BACK-BIASED FACE TARGET
SPUTTERING

RESPONSE TO OFFICE ACTION

Commissioner for Patents
PO Box 1450
Alexandria, VA 22313-1450

Sir:

Amendment to the claims start on page 2.

Remarks start on page 9.